

owner or operator of a facility or emission source subject to the rules specified in subsection (a), (b) or (c) may operate the emission source according to the plan and schedule as submitted.

- e) The plan and schedule shall meet the requirements of 35 Ill. Adm. Code 201, Subpart H, including specific interim dates as required in 35 Ill. Adm. Code 201.242.

(Source: Adopted at 11 Ill. Reg. 16706, effective September 30, 1987)

Section 215.408 Heatset Web Offset Lithographic Printing

- a) No owner or operator of a heatset web offset lithographic printing facility, located in Cook, DuPage, Kane, Lake, Macoupin, Madison, McHenry, Monroe, St. Clair or Will County, emitting over 100 tons/year of organic material, in the absence of pollution control equipment, may cause or allow the operation of a heatset web offset press unless:

- 1) An incinerator system is installed and operated that oxidizes at least 90 percent of the organic materials (measured as total combustible carbon) in the dryer exhaust airstream to carbon dioxide and water; or
- 2) The fountain solution contains no more than eight (8) percent, by weight, of volatile organic material and a condensation recovery system is installed and operated that removes at least 75 percent of the non-isopropyl alcohol organic materials from the dryer exhaust airstream.

- b) No owner or operator of a heatset web offset lithographic printing facility, located in a county other than Cook, DuPage, Kane, Lake, Macoupin, Madison, McHenry, Monroe, St. Clair or Will County, emitting over 100 tons/year of organic material, in the absence of pollution control equipment, may cause or allow the operation of a heatset web offset press unless the fountain solution contains no more than eight (8) percent, by weight, of volatile organic material.

(Source: Added at 11 Ill. Reg. 16706, effective September 30, 1987)

SUBPART Q: LEAKS FROM SYNTHETIC ORGANIC CHEMICAL AND POLYMER MANUFACTURING EQUIPMENT

Section 215.420 Applicability

The provisions of Sections 215.421 through 215.429 of this subpart shall apply to all plants in the State of Illinois which manufacture synthetic organic chemicals and polymers, except those located in any of the following counties: Will, McHenry, Cook, DuPage, Lake, Kane, Madison, St. Clair, Macoupin, and Monroe. The provisions of Section

215.430 through 215.438 shall apply to the counties specifically enumerated above. In addition, if any county is redesignated as non-attainment by the USEPA subsequent to December 31, 1987, the owner or operator of a plant located in that county shall comply with the requirements of Sections 215.430 through 215.438 upon the effective date of the redesignation.

(Source: Added at 11 Ill. Reg. 20829, effective December 14, 1987)

Section 215.421 General Requirements

The owner or operator of a plant which has more than 1,500 components in gas or light liquid service, which components are used to manufacture the synthetic organic chemicals or polymers listed in Appendix D, shall conduct leak inspection and repair programs in accordance with this Subpart for that equipment containing more than 10 percent volatile organic material as determined by ASTM method E-260, E-168, and E-169, incorporated by reference in Section 215.105. A component shall be considered to be leaking if the volatile organic material concentration exceeds 10,000 ppm when measured at a distance of 0 cm from the component. The provisions of this Subpart are not applicable if the products listed in Appendix D are made from natural fatty acids for the production of hexadecyl alcohol.

(Source: Adopted at 11 Ill. Reg. 20829, effective December 14, 1987)

Section 215.422 Inspection Program Plan for Leaks

The owner or operator of a synthetic organic chemical or polymer manufacturing plant subject to Section 215.420 shall prepare an inspection program plan which contains, at a minimum:

- a) An identification of all components and the period in which each will be monitored pursuant to Section 215.422;
- b) The format for the monitoring log required by Section 215.423;
- c) A description of the monitoring equipment to be used pursuant to Section 215.422; and
- d) A description of the methods to be used to identify all pipeline valves, pressure relief valves in gaseous service, all leaking components, and the ball and plug valves and pumps exempted under Section 215.422(h) such that they are obvious and can be located by both plant personnel performing monitoring and Agency personnel performing inspections.

(Source: Adopted at 9 Ill. Reg. 13960, effective August 28, 1985)